



NVLUS 013C1

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Basol et al.  
Appl. No. : 10/654,542  
Filed : September 2, 2003  
For : CONSTANT LOW FORCE  
WAFER CARRIER FOR  
ELECTROCHEMICAL  
MECHANICAL PROCESSING  
AND CHEMICAL MECHANICAL  
POLISHING  
  
Examiner : Eileen P. Morgan  
Group Art Unit : 3723

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 19, 2007

(Date)

Tina Chen, Reg. No. 44,606

**AMENDMENT ACCOMPANYING RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to examination of the above-captioned application, please consider the amendments and remarks as set forth herein.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.